

**RESPONSE AFTER FINAL
EXPEDITED PROCEDURE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:	Confirmation No.: 2221
Myounggoo LEE et al.	Art Unit: 1795
Application No.: 10/658,460	Examiner: Rodney Glenn McDONALD
Filed: September 10, 2003	Attorney Docket No.: 029567-00004
For: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS SPUTTERING FILM FORMING APPARATUS	

DO NOT ENTER: /RM/

04/23/2008

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 16, 2008

Sir:

In reply to the February 4, 2008, Office Action, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, begin on page 2;
and

Remarks begin on page 4.